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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

-) Art Unit: 1722
-)
-) Confirmation No.: 9556
-)
-) *I hereby certify that this correspondence is being deposited with the United Postal Service as first class mail in an envelope addressed to: Mailstop Petition / Commissioner for Patents / PO Box 1450 / Alexandria, Virginia 22313-1450 on January 10, 2008.*
-) 
Gerald T. Shekleton
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-)

Applicant(s): Hiroshi Inagaki et al.
Serial No.: 10/588,533
Filed: August 7, 2006
For: **Single Crystal Semiconductor
Manufacturing Apparatus and
Method**
Examiner: Felisa Carla Hiteshew

AMENDMENT

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

The Office Action of September 24, 2007 and the following amendments and remarks are made in response thereto.